Electronic Acknowledgement Receipt				
EFS ID:	1218466			
Application Number:	10607869			
Confirmation Number:	7086			
Title of Invention:	METHOD OF FORMING SILICON-ON-INSULATOR COMPRISING INTEGRATED CIRCUITRY			
First Named Inventor:	Zhongze Wang			
Customer Number:	21567			
Filer:	Jennifer J. Taylor			
Filer Authorized By:				
Attorney Docket Number:	MI22-2343			
Receipt Date:	25-SEP-2006			
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Time Stamp:	18:05:39			
Application Type:	Utility			
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Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Request for Certificate of Correction	reqforcoc.pdf	89754	no	3

Warnings:	
Information:	
Total Files Size (in bytes):	89754

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.